



Docket No.: 204552030700
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yoshiaki UEDA et al.

Application No.: 10/715,025

Confirmation No.: 3319

Filed: November 18, 2003

Art Unit: 2828

For: SEMICONDUCTOR LASER DEVICE AND
MANUFACTURING METHOD THEREFOR

Examiner: T. T. Van Roy

AMENDMENT UNDER 37 CFR 1.111

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In connection with the Request for Continued Examination (RCE) filed concurrently herewith and in response to the Office Action dated April 7, 2006, please amend this application as follows

Amendments to the Claims begin on page 2.

Remarks/Arguments begin on page 4.